Se	arcn Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/998,895	TENG ET AL.	
Examiner	Art Unit	
Amelia Rutledge	2176	

	SEAR	CHED	
Class	Subclass	Date	Examiner
715	500	3/15/2005	AR
715	751	3/15/2005	AR
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INI	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner

DATE	
	EXMR
3/15/2004	AR
3/15/2004	AR
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